



Docket No.: SON-1718  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Yasukiyasu Sugano et al.

Application No.: 09/478,812

Filed: January 7, 2000

For: PROCESS FOR PRODUCING THIN FILM  
SEMICONDUCTOR DEVICE AND LASER  
IRRADIATION APPARATUS

Art Unit: 2815

Examiner: E. Lee

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SEP 02 2004

TECH CENTER 2000

#30/C  
J. McQuinn  
10/7/04

**PRELIMINARY AMENDMENT SUBMITTED WITH REQUEST FOR CONTINUED  
EXAMINATION (RCE)**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

Prior to examination on the merits, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.